## REQUEST

## CONTINUED EXAMINATION (RCE) TRANSMITTAL

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995.

See The American Inventors Protection Act of 1999 (AIPA).

Application Number	10/681,481
Filing Date	October 8, 2003
First Named Inventor	Paul A. Farrar
Group Art Unit	1746
Examiner Name	Joy L. Watson
Attorney Docket Number	1303.112US1
Customer No.	21186

This is a Request for Continued Examination (RCE) under 37 CFR § 1.114 of the above-identified application entitled

## METHOD OF CLEANING SEMICONDUCTOR SURFACES.

Submission required under 37 C.F.R. § 1.114

- Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on .
- 2. \_\_ Consider the arguments in the Appeal Brief or Reply Brief previously filed on .
- X Preliminary Amendment (9 pages) is enclosed.
- 4. \_ New power of attorney ( pages) is enclosed.
- 5. \_ Information Disclosure Statement is enclosed ( pages), with:
  - Form 1449 (pages)
    - Copies of IDS Citations ()
- 6. Yelease charge Deposit Account 19-0743 in the amount of \$810.00 to pay the RCE filing fee required under C.F.R. § 1.17(e).
- 7. X The Commissioner is hereby authorized to credit overpayments or charge any fees set forth in 37 CFR §§ 1.16 through 1.18 to Deposit Account No. 19-0743.
- 8. X Petition for Extension of Time in the prior application (1 page) is enclosed along with authorization to charge Deposit Account 19-0743 in the amount of \$460.00 to pay the extension fee.
- Others:

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

By: Atty: David C. Peterson Reg. No. 47,857

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 40 of December, 2007.

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Signature

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